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INFORMATION DISCLOSURE	Application Number	09/892,469				
				Filing Date	June 28,2001	
STATEMENT BY APPLICANT				First Named Inventor	B. Malo	
				Group Art Unit	2874	
(use as many sheets as necessary)			cessary)	Examiner Name		
Sheet	1	of	2	Attorney Docket Number	702P03US-1	

U.S. Pat Number	ent Document	U.S. PATENT DOC		
	Kind Code ² (If known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
5 367	588	Hill et al	Nov 22/94	
				
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		5 367 588	5 367 588 Hill et al	5 367 588 Hill et al Nov 22/94

				FORE	IGN PATENT DOCUMEN	rs		
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Initials*		Office ³	Number ⁴	Kind Code ^s (<i>if known</i>)	Applicant of Cited Document	Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear	T6
 								
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		Complete if Known	
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INFORMATION D	ISCLOSURE		June 28,2001
		First Named Inventor	B. MAlo
STATEMENT BY	ALL LIOAN	Group Art Unit	
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	2	Attorney Docket Number	702P03US-1

		OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS	2					
Examiner Initials	Cite No.1	item (book, magazine, journal, senal, symposium, catalog, etc.), data, paga(3), votalito-13360 halifoot (5), publisher, city and/or country where published.	1,5					
	C-1	Phase Mask Technology Overview - Impact of Phase Mask						
HK.		Technique in Guided Wave Device Production - S.K. Kuma et al OPS Technology Inc.						
•	C-3	Transmission Edge Filters for Power Equalization of EDFA's -						
: D:	U-4	The Destarion Weaken last latters - 1						
. V	C-3	Lawrence Chen et al - IEEE Photonics Technology Letters - Vol. 12, No. 7, July 2000 - pp 822-824 Laser Trimming Method for Adjustment of Grating Offset in Optical Fiber Grating Couplers - Yokota et al- Dept. of Systems	3					
15		Engineering, Faculty of Engineering, Ibaraki Univ Japan						
3/2	C-4	Bragg Gratings Fabricating in Monomode Photosensitive Optical Fiber by NV Exposure Through a Phase Mask - K.O. Hill et al -						
	-	Appl Phys. Lett. 62 (10) 8 March 1993 - pp 1035 - 1037	_					
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